

NEMS/MEMS AND MICROTAS

G

ICMAT 2011

INTERNATIONAL CONFERENCE ON MATERIALS
FOR ADVANCED TECHNOLOGIES

26 JUNE - 1 JULY, SINGAPORE



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Materials Research Society
SINGAPORE



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NEMS/MEMS and microTAS

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Contents

1	Organizer & Committee Session Information
2	• <i>Program Overview</i>
3	• <i>Session Schedule</i>
26	Abstracts
105	Author Index
112	Information & Services
	• <i>Activity Locator</i>
	• <i>Useful Information</i>
	• <i>Speaker Guides</i>

- 12:15
p.56 G10-4
Wireless Imaging Module Assembly and Integration for Capsule Endoscopic Applications
Riyas KATAYAN^{1*}, Ruiqi LIM², Sin Win SHWE¹, Kripesh VAIDYANATHAN³
¹*Minituarized Medical Device, Institute of Microelectronics, Agency for Science, Technology and Research, Singapore*, ²*Minituarized Medical Device, Institute of Microelectronics, Singapore*, ³*Institute of Microelectronics, Agency for Science, Technology and Research, Singapore*
- 12:30
p.56 G10-5
Tagging for Capsule Endoscopy Localization
Ruiqi LIM¹, Riyas KATAYAN², Sin Win SHWE¹, Kripesh VAIDYANATHAN³
¹*Minituarized Medical Device, Institute of Microelectronics, Singapore*, ²*Minituarized Medical Device, Institute of Microelectronics, Agency for Science, Technology and Research, Singapore*, ³*Institute of Microelectronics, Agency for Science, Technology and Research, Singapore*
- 12:45
p.57 G10-6
A Tunable External Cavity Laser Using A Micromachined Silicon Flexure For Atomic Spectroscopy
Ho-Chiao CHUANG^{1*}, Kuo-Yuan HUANG¹
¹*Mechanical Engineering, National Taipei University of Technology, Taiwan*

Fabrication

Fri - 1 Jul 11 | 14:00 - 16:00 | Room 320

Session Chair(s): Guillaume Vienne & Min Tang

- 14:00
p.57 G11-1 (Invited)
Fabrication of High-aspect Ratio Micro/nano Structures with X-ray Lithography/LIGA Technique
Linke JIAN^{1*}
¹*Singapore Synchrotron Light Source, National University of Singapore, Singapore*
- 14:30
p.58 G11-2 (Invited)
Ambient Energy Harvesting: from Macro to Nano Devices
Philippe BASSET^{1*}
¹*ESYCOM-ESIEE Paris, Université Paris-Est, France*
- 15:00
p.58 G11-3
Microfluidics for Solar-powered Photocatalysis
Ning WANG¹, Yu-Peng ZHANG², Lei LEI¹, H.L.W. CHAN¹, Xu-Ming ZHANG^{3*}
¹*The Hong Kong Polytechnic University, Hong Kong SAR, China*, ²*Hong Kong Polytechnic University, Hong Kong SAR, China*, ³*Nanyang Technological University, Singapore*
- 15:15
p.59 G11-4
Fabrication of Microactuator based on Low Cost and High Resolution X-ray Lithography
Pongsak KERDLAPEE^{1*}, Anurat WISITSORAAT², komgrit LEKSAKUL¹, Adisorn TUANTRANONT²
¹*Industrial Engineering, Chiangmai University, Thailand*, ²*Nanoelectronics and Micro-Electro-Mechanical Systems Laboratory, National Electronics and Computer Technology, Thailand*

- 15:30**
p.60 **G11-5**
Characterization of local stress in doped poly silicon film by poly silicon cantilever structures
Kai Yeow TAN^{1*}, Qingxin ZHANG¹, Kim Bock CHUA², Xiang Zheng TAY¹, Guang De GAN³
¹*Institute of Microelectronics, Agency for Science, Technology and Research, Singapore,* ²*Fabs, Institute of microelectronics, Singapore,* ³*Fabs, Institute of microelectronics, Agency for Science, Technology and Research, Singapore*
- 15:45**
p.60 **G11-6**
Fabrication and Performance Characterization of a Disposable Micropump Actuated by Piezoelectric-disc
Ling Ling SUN^{1*}, Lingna LI¹, Jin Lan GUO¹, Siti FATIMATUZZAHRA BTE R¹, Shanzhong WANG¹
¹*Temasek Microelectronics Center, Temasek Polytechnic, Singapore,* ²*Temasek Polytechnic, Singapore*
- 16:00**
p.61 **G11-7**
Investigation of Simple Process Technology for the Fabrication of Valveless Micropumps
Jumril YUNAS^{1*}, Juliana JOHARI¹, Ali Reza BAHADORIMEHR¹, Burhanuddin YEOP MAJLIS¹, Ilie GEBESHUBER¹
¹*Institute of Microengineering and Nanoelectronics, Universiti Kebangsaan Malaysia, Malaysia*
- 16:15**
p.61 **G11-8**
Hydrosilane Modification of Metals: An Exploratory Study
Janis MATSONS^{1*}, Barry ARKLES¹, Yun Mi KIM¹, Youlin PAN¹, Eric EISENBRAUN², Alain KALOYEROS²
¹*Research and Development, Gelest Inc, United States,* ²*College of Nanoscale Science and Engineering, State University of New York, United States*

MEMS Sensors

Fri - 1 Jul 11 | 16:30 - 18:00 | Room 320

Session Chair(s): Qingxin Zhang & Tupei Chen

- 16:30**
p.62 **G12-1 (Invited)**
Micro- and Nanofibers: a Platform for making Optical Microdevices
Guillaume VIENNE^{1*}
¹*Advanced Concepts Group, Data Storage Institute, Singapore*
- 17:00**
p.62 **G12-2**
Challenges and Solutions for Fabricating Isolation Trenches for High Aspect Ratio Sensors
Rahul AGARWAL^{1*}, Jin XIE², Kia Hian LAU¹, Praveen KUMAR SAMPATH¹, Nagarajan RANGANATHAN³, Janak SINGH¹, Ming Lin Julius TSAI¹, Kai Yeow TAN¹
¹*Institute of Microelectronics, Singapore,* ²*Sensors and Actuators Microsystems, Institute of Microelectronics, Singapore,* ³*Institute of Microelectronics, Agency for Science, Technology and Research, Singapore*

Symposium G Poster Session

Wed - 29 Jun 11 | 14:00 - 16:30 | Gallery East

- Sn. 1**
p.65 G-PO3-1
Mechanical Stopper Material Evaluation and Assembly Process Improvement of MEMS Tri-axial Force Sensor for Sensorised Guidewires Application
Muhammad HAMIDULLAH^{1*}, Liang LOU², Li Shiah LIM³, Woo-tae PARK¹, Hanhua FENG¹
¹Miniaturized Medical Devices, Institute of Microelectronics, Singapore, ²National University of Singapore, Singapore, ³Miniaturized Medical Device, Institute of Microelectronics, Singapore
- Sn. 2**
p.66 G-PO3-2
Fabrication of a New Peltier Device with a Coaxial Thermocouple
Yosuke MURAYAMA^{1*}, Shigeo YAMAGUCHI¹
¹Electrical, Electronic and Information Engineering, Kanagawa University, Japan
- Sn. 3**
p.66 G-PO3-3
Proposal and Fabrication of a Precisely Temperature-controlled NN-type Peltier Device with a T-shaped Stage
Nobuyuki SUZUKI^{1*}, Shigeo YAMAGUCHI¹
¹Electrical, Electronic, and Information Engineering, Kanagawa University, Japan, ²Electrical, Electronic and Information Engineering, Kanagawa University, Japan
- Sn. 4**
p.67 G-PO3-4
Fabrication of a Thin-film Peltier Device Based on InSb
Tatsuya ISHII^{1*}, Hideyuki HOMMA¹, Shigeo YAMAGUCHI¹
¹Electrical, Electronic and Information Engineering, Kanagawa University, Japan, ²Electrical, Electronic and Information Engineering, Kanagawa University, Japan
- Sn. 5**
p.67 G-PO3-5
Oscillating Micromixers on a Compact Disc
Chih-Hsin SHIH^{1*}, Daniel YEN¹
¹Chemical Engineering, Feng Chia University, Taiwan
- Sn. 6**
p.68 G-PO3-6
Robust Sequential Flow Controls on the Centrifugal Platform
Chih-Hsin SHIH^{1*}, Hou-Jin WU¹, Wen-Hao CHEN¹
¹Chemical Engineering, Feng Chia University, Taiwan
- Sn. 7**
p.68 G-PO3-7
Design and Modeling of Platinum Thin Film Microheater for High Temperature Microtensile Test Application
Wan Chia ANG^{1*}, Man I LEP², Ming Lin Julius TSAI³, Kam Chew LEONG², Chuan Seng TAN⁴
¹School of Electrical and Electronics Engineering, Nanyang Technological University, Singapore, ²Institute of Microelectronics, Agency for Science, Technology and Research, Singapore, ³Global Foundries Singapore Private Limited, Singapore, ⁴School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore
- Sn. 8**
p.69 G-PO3-8
Fabrication of a Portable Thermal Cycler Using a PN Sandwich-structure Peltier Device
Yoko OKUWAKI^{1*}, Shigeo YAMAGUCHI¹
¹Electrical, Electronic and Information Engineering, Kanagawa University, Japan

- Sn. 41**
p.87 G-PO3-41
Direct Writing of Closed Channels in Silica by MeV Ion Beam Lithography
Nitipon PUTTARAKSA^{1,2*}, Mari NAPARI¹, Orapin CHIENHAVORN³, Rattanaorn NORARAT¹, Timo SAJAVAARA¹, Mikko LAITINEN¹, Somsorn SINGKARAT⁴, Harry J. WHITLOW¹
¹Department of Physics, University of Jyväskylä, Finland, ²Plasma and Beam Physics Research Facility, Department of Physics and Materials Science, Faculty of Science, Chiang Mai University, Thailand, ³Department of Chemistry, Kasetsart University, Thailand, ⁴Thailand Center of Excellence in Physics, CHE, Thailand
- Sn. 42**
p.87 G-PO3-42
Dynamic Field Responsive Nanoparticle Aggregates for Continuous Microfluidic Protein Separations
S.H. Sophia LEE¹, Saif A. KHAN², T. Alan HATTON³
¹Singapore-MIT Alliance, National University of Singapore, Singapore, ²Department of Chemical and Biomolecular Engineering, National University of Singapore, Singapore, ³Department of Chemical Engineering, Massachusetts Institute of Technology, United States
- Sn. 43**
p.88 G-PO3-43
Hydrogel Microstructure for Single Cell Analysis in a Microfluidic Device
Jitkai CHIN^{1*}, Kean How CHEAH², kai Seng KOH²
¹Department of Chemical and Environmental Engineering, University Nottingham Malaysia, Malaysia, ²University Nottingham Malaysia, Malaysia
- Sn. 44**
p.88 G-PO3-44
Development of Multiple-step SOI DRIE Process for Superior Notch Reduction at Buried Oxide.
Praveen KUMAR SAMPATH^{1*}
¹Institute of Microelectronics, Singapore
- Sn. 45**
p.89 G-PO3-45
Thick-film Deposition of High-viscous Liquid Photopolymer
Jafar ALVANKARIAN¹, Mitra DAMGHANIAN¹, Burhanuddin YEOP MAJLIS^{1*}
¹Institute of Microengineering and Nanoelectronics, Universiti Kebangsaan Malaysia, Malaysia
- Sn. 46**
p.89 G-PO3-46
Effect of Temperature on the Electrical and Gas Sensing Properties of Polyaniline and Multiwall Carbon Nanotube Doped Polyaniline Composite Thin Films
Subodh SRIVASTAV^{1*}, Sumit KUMAR¹, Vipin Kumar JAIN¹, YK VIJAY¹
¹Department of Physics, University of Rajasthan, India
- Sn. 47**
p.90 G-PO3-47
On the Way to the Bionic Man - A Novel Approach to MEMS Based on Biological Sensory Systems
Salmah B. KARMAN¹, Mark O. MACQUEEN², Tina R. MATIN³, S. Zaleha M. DIAH⁴, Jeanette MUELLER⁵, Jumril YUNAS⁶, Teresa MAKARCZUK⁷, Ilse C. GEBESHUBER^{8*}
¹Institute of Microengineering and Nanoelectronics, Universiti Kebangsaan Malaysia, Malaysia, ²Aramis Technologies Sdn. Bhd., Malaysia, ³Zoology Museum, University of Malaya, Malaysia, ⁴Transtroom, Austria, ⁵Institute of Applied Physics, Vienna University of Technology, Austria

- Sn. 48**
p.90
G-PO3-48
Biomolecule Separation Using Electrophoresis Enhanced Deterministic Lateral Displacement
Kerwin Zeming KWEK^{1*}, Yong ZHANG², Hong Yee LOW³
¹Bioengineering, National University of Singapore, Singapore, ²National University of Singapore, Singapore, ³Institute of Materials Research and Engineering, Singapore
- Sn. 49**
p.91
G-PO3-49
Silicon Probes for Cochlear Auditory Nerve Stimulation and Measurement.
Nishant LAWAND^{1,2*}, Paddy FRENCH¹, Jeroen BRIAIRE³, Johan H.M. FRIJNS³
¹Faculty of Electrical Engineering, Mathematics and Computer Science, Delft University of Technology, Netherlands, ²Electronic Instrumentation Laboratory, Delft University of Technology, Netherlands, ³Ear, Nose and Throat Department., Leiden University Medical Center., Netherlands
- Sn. 50**
p.91
G-PO3-50
NEMS-based Innervation of Materials
Ille C. GEBESHUBER^{1,2*}, Joannette MUELLER³, Mark O. MACQUEEN⁴
¹Institute of Microengineering and Nanoelectronics, Universiti Kebangsaan Malaysia, Malaysia, ²Institute of Applied Physics, Vienna University of Technology, Austria, ³Trustroom, Austria, ⁴Aramis Technologies Sdn. Bhd., Malaysia
- Sn. 51**
p.92
G-PO3-51
Nano-scaled Optical Powermeter Development on Silicon Platform
Ji Fang TAO^{1*}, Aibin YU², Hong CAP, Jian WU³, Ai-Qun LIU⁴
¹Nanyang Technological University, Singapore, ²Institute of Microelectronics, Agency for Science, Technology and Research, Singapore, ³Institute of Microelectronics, Singapore, ⁴Beijing University of Posts and Telecommunications, China, ⁵School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore
- Sn. 52**
p.92
G-PO3-52
A Ring Resonator Pressure Sensor Based on Optical Force
Xin ZHAO^{1*}, Hong CAP, Ming Lin Julius TSAP, Xin-ming JI², Jia ZHOU³, Min-Hang BAO⁴, Yi-Ping HUANG⁵, Ai-Qun LIU⁶
¹School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore, ²Institute of Microelectronics, Singapore, ³Institute of Microelectronics, Agency for Science, Technology and Research, Singapore, ⁴Fudan University, China
- Sn. 53**
p.93
G-PO3-53
Controllable Optical Activity in Metamaterial through MEMS
Wu ZHANG^{1*}, Weiming ZHU¹, Yuan Hsing FU², Ji Fang TAO³, Dim-Lee KWONG³, Patrick G.Q LO⁴, Ai-Qun LIU⁵
¹Nanyang Technological University, Singapore, ²Data Storage Institute, Singapore, ³Institute of Microelectronics, Singapore, ⁴School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore
- Sn. 54**
p.93
G-PO3-54
Stopping Micro-Particle on the Ring/Waveguide by Using Double Coupled Ring Resonator
Ye Feng YU^{1*}, Hong CAP, Jifang TAO², Min REN³, Tarik BOUROUINA⁴, Ai-Qun LIU⁵
¹Nanyang Technological University, Singapore, ²Institute of Microelectronics, Singapore, ³ESIEE-Paris, University of Paris-Est, France, ⁴School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore

G11-7

Investigation of Simple Process Technology for the Fabrication of Valveless Micropumps

Jumril YUNAS^{1*}, Juliana JOHARI¹, Ali Reza BAHADORIMEHR¹, Burhanuddin YEOP MAJLIS¹, Ilie GEBESHUBER¹

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Micropumps are essential components of the miniaturization of fluidic systems to enable liquid injection from the storage to a fluidic system and to control fluidic flow in a variety of applications, such as integrated fluidic channel arrangements in chemical analysis systems or electronics cooling, as well as for drug delivery systems. Micropumps offer important advantages because they are compact and small in size. They can operate using small sample volumes and provide rapid respond time. In this paper we discuss a simple and rapid process technique for the fabrication of valveless micro-pumps. The technique utilizes standard MEMS technique by using a double sided wet etching technique with an additional adhesive bonding technique. Anisotropic wet etching at both sides of silicon substrate is implemented at the same time which reduce the processing steps up to 50%. The diffuser and a nozzle element of the pump, as well as a 150 μm thick silicon membrane are designed and fabricated using only 3 pattern process steps. An actuator-chamber and a pump-chamber with a depth of 250 μm respectively is formed after 250 minutes KOH etching, while the diffuser/nozzle element with a depth of 50 μm are sequentially formed after chambers forming. A piezoelectric disc working at the frequency 1.5 kHz is bonded on to the back side of the silicon membrane using conductive epoxy material. Finally, the use of a standard thick photoresist as the adhesive material for the bonding will also be discussed in detail. The flow rate was measured and the process reproducibility was proven which show a good prospect for the future development of miniaturized pump for biomedical application.

G11-8

Hydridosilane Modification of Metals: An Exploratory Study

Janis MATISONS^{1*}, Barry ARKLES¹, Yun Mi KIM¹, Youlin PAN², Eric EISENBRAUN², Alain KALOYEROS²

¹Research and Development, Gelest Inc, United States, ²College of Nanoscale Science and Engineering, State University of New York, United States

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The interaction of hydridosilanes with oxide-free metal substrates was evaluated in order to determine their potential for surface modification analogous to alkoxy-silanes with metal oxide substrates. Under mild conditions, trihydrido-silanes interact with a variety of clean, hydrogenated and fresh metal and metalloid surfaces, including titanium, silicon and gold. In contrast, monohydrido-silanes appear to have minimal interaction. All classes of hydrido-silanes have minimal interaction with anhydrous oxide surfaces. Results suggest that surface modification with trihydrido-silanes may provide a route for generating self-assembled monolayers on metal substrates. The synthesis of new trihydrido-silanes is described, while contact angle, FTIR and XPS data for all modified surfaces are provided.

G-PO3-47

On the Way to the Bionic Man - A Novel Approach to MEMS Based on Biological Sensory Systems

Salmah B. KARMAN¹, Mark O. MACQUEEN², Tina R. MATIN³, S. Zaleha M. DIAH⁴, Jeanette MUELLER⁵, Jumril YUNAS¹, Teresa MAKARCZUK⁶, Ilse C. GEBESHUBER^{1,2*}

¹Institute of Microengineering and Nanoelectronics, Universiti Kebangsaan Malaysia, Malaysia, ²Aramis Technologies Sdn. Bhd., Malaysia, ³Zoology Museum, University of Malaya, Malaysia, ⁴Trustroom, Austria, ⁵Institute of Applied Physics, Vienna University of Technology, Austria
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The human senses are of extraordinary value, but we cannot change them, even if this proves to be a disadvantage in our modern times. However, we can assist, enhance and expand these senses via MEMS. A push-pull analysis was performed to investigate market needs in relation to biological senses reported in the literature. Some animals and even humans (with artificial lenses after cataract surgery) can see in the infrared and ultraviolet range; related MEMS with IR/UV sensitivity might assist to determine the status of organisms. The hearing capabilities of bats (ultrasound) can inspire echolocation. Butterflies have exquisite thermoregulation; this might lead to MEMS that are better protected from overheating and undesirable convection. Mice can smell important information about another mouse's immune system and mosquitoes detect minuscule amounts of carbon dioxide and lactic acid; such bio-inspired MEMS could serve as medical or environmental scanners. The senses for magnetism, vibrations and electroreception that are used by animals might satisfy the need for MEMS for navigation and orientation. MEMS that are skillfully added to the human body can provide additional perceptory data. The challenge here will be to process the MEMS generated data into readily understandable information and provide them to the user as an add-on within an already existing sensory bandwidth. This can happen in three ways: the expensive method adds information to the upper or lower end of the (compressed) sensory bandwidth; the additive method enhances the original information by transforming it and in the mutative method completely reformats the available information. The extraordinary plasticity of the human brain will allow the user to adapt to the amended sensory environment relatively fast, providing unparalleled novel abilities. Future research will identify where already available MEMS excel and which outstanding properties of sensory systems can easily be replicated by 'off the shelf' systems.

G-PO3-48

Biomolecule Separation Using Electrophoresis Enhanced Deterministic Lateral Displacement

Kerwin Zeming KWEEK^{1*}, Yong ZHANG², Hong Yee LOW³

¹Bioengineering, National University of Singapore, Singapore, ²National University of Singapore, Singapore, ³Institute of Materials Research and Engineering, Singapore
**Corresponding author: g0801509@nus.edu.sg *Presenter*

Biomolecules such as Deoxyribonucleic acid (DNA), Ribonucleic acid (RNA) and proteins are key analytes in medical diagnostic, therapeutic and research processes. Separation of these biomolecules in its native state would greatly enhance downstream testing and analysis. This project proposes a novel method of a native biomolecule separation technique employing the use of deterministic lateral displacement (DLD) separation enhanced with electrophoresis. With reported particle size deviation of less than 20nm and potential analyte purity of greater than 99%, DLD has the capacity to accurately separate particle based on size. The trade-off for such high precision and efficiency would be a very limited separating range for each DLD device. Hence a proposed use of electrophoresis is needed to enhance the potential of DLD device to selectively control the separation of charge biomolecules (DNA, RNA and Proteins). The method proposed in this project would

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¹*Institute of Microengineering and Nanoelectronics, Universiti Kebangsaan Malaysia, Malaysia,* ²*Aramis Technologies Sdn. Bhd., Malaysia,* ³*Zoology Museum, University of Malaya, Malaysia,* ⁴*trustroom, Austria,* ⁵*Institute of Applied Physics, Vienna University of Technology, Austria*

[#]*Corresponding author: gebeshuber@iap.tuwien.ac.at [†]Presenter*

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MEMS that are skillfully added to the human body can provide additional perceptory data. The challenge here will be to process the MEMS generated data into readily understandable information and provide them to the user as an add-on within an already existing sensory bandwidth. This can happen in three ways: the expensive method adds information to the upper or lower end of the (compressed) sensory bandwidth; the additive method enhances the original information by transforming it and in the mutative method completely reformats the available information. The extraordinary plasticity of the human brain will allow the user to adapt to the amended sensory environment relatively fast, providing unparalleled novel abilities. Future research will identify where already available MEMS excel and which outstanding properties of sensory systems can easily be replicated by 'off the shelf' systems.

greatly enhance the flexibility of the DLD device to allow separation of a wide range of biomolecules. With the addition of another separating mechanism, its combined effect of electrophoresis and DLD would significantly increase the range of particle separating applications and separation efficiency.

G-PO3-49

Silicon Probes for Cochlear Auditory Nerve Stimulation and Measurement.

Nishant LAWAND^{1,2*}, Paddy FRENCH¹, Jeroen BRIAIRE³, Johan H.M. FRIJNS³

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Cochlear Implant's (CIs) are devices that provides sense of sound to people who are deaf or severely hard of hearing. Electrode array, the main component is placed in close contact with neurons to provide reliable excitation to the auditory nerve. The important issue with CIs is electrode design and its placement. The array should be placed close to the modiolar wall of cochlea. Available cochlear arrays are hand assembled bundled wires coated with silicone for biocompatibility. These are limited in electrode count (16-24), due to their large size relative to the size of scala tympani (ST). Arrays should be flexible for easy surgical insertion and biocompatible in hostile and saline warm environment. Silicon semiconductor micro-fabrication is an promising technology for advanced CI electrode arrays which will replace the traditional fabrication method. We present a new design for silicon CI electrode array. It consists of a Silicon substrate on which 16 Platinum-Iridium contact points provides stimulation to nerve endings. Three different configurations are considered for current density distribution, as excess current causes overstimulation with damage to residual hearing. Prior to fabrication and placement in ST we will fabricate stiff probes which would puncture the cochlear auditory nerve. This is in order to check the stimulation pattern by passing current through the array and to realize the mechanical strength of the probe. Simulation of probe was done in the volume conduction cochlear model developed at LUMC. In this model to mimic the tonotopic organization of cochlea the fibers were arranged according to frequency. High frequency fibers at base and low frequency at apex of the model. A minimum current of 10^{-2} mA to a maximum of 0.5 mA is passed through the probe placed in the bundle of nerve fibers for stimulation at contact points of the probe.

G-PO3-50

NEMS-based Innervation of Materials

Ilse C. GEBESHUBER^{1,2*}, Jeanette MUELLER³, Mark O. MACQUEEN⁴

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We propose a concept for a novel "homogenous" material that is assembled by billions of coupled reactive NEMS. This new approach shall enable the material to show specific reactions to external inputs. Since the NEMS can communicate with each other, the reaction to the external input can be local (indicator) or general (reactive). By implementing this material into buildings, clothing or even food, it would be possible to create a virtual neural system in objects. The presentation will give an outlook on the potential of such an approach in art, science and technology and the possible impact on the life of future generations.

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G-PO3-51

Nano-scaled Optical Powermeter Development on Silicon Platform

Ji Fang TAO^{1*}, Aibin YU², Hong CAI³, Jian WU⁴, Ai-Qun LIU⁵

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This paper reports a silicon-based MEMS optical power detector with on-chip measurement ability. The optical power is detected by an integrated electron-tunneling displacement transducer, in which optical force is employed as the bridge between optical energy and mechanical energy transition. Compared with the traditional optical power detectors which are based on photo absorption, this optical power detector has small size (0.08 mm × 0.3 mm), low thermal noise (0.03 V/°C), large measurement range (> 20 mW) and wavelength independence.

The proposed optical power detector consists of an optical waveguide, a cantilever beam, a pair of metalized nano-tips, and a parallel-plate electrostatic actuator. When the light transmits in the waveguide, its evanescent field can excite dipoles in the adjacent cantilever beam and generate an attractive optical force. Therefore, a small displacement of the cantilever beam is generated, whose magnitude is determined by the input optical power and the spring constant of the cantilever beam. In order to detect this displacement, a high resolution tunneling transducer, which consists of the metalized nano-tips and the parallel-plate electrostatic actuator, is integrated.

In conclusions, a high-performance silicon-based optical power detector has been developed by MEMS technology. As it possesses the advantages of small size (0.08 mm × 0.3 mm), large measurement range (> 20mW), and on-chip measurement ability, it has potential applications in silicon-photonics-integration chips and lab-on-chip analysis systems.

G-PO3-52

A Ring Resonator Pressure Sensor Based on Optical Force

Xin ZHAO¹, Hong CAI², Ming Lin Julius TSAI³, Xin-ming JI⁴, Jia ZHOU⁵, Min-Hang BAO¹, Yi-Ping HUANG¹, Ai-Qun LIU^{1*}

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A Nano-opto-mechanical Systems (NOMS) ring resonator pressure sensor based on optical force is reported. This sensor array which is similar as Wheatstone-bridge pressure sensor consists of a square diaphragm, a ring resonator and four waveguides. By applying a pressure ranging from 100 kPa to 800 kPa, the output intensity modulation of 60% is obtained. Compared with other single waveguide and ring optical pressure sensor, the proposed ring pressure sensor array has the advantages such as higher sensitivity and resolution, which could be applied to acoustic pressure sensor, cell mass measurement etc.

The ring resonator pressure sensor consists of a 500 × 500 μm² diaphragm, a ring resonator and four waveguides. The waveguides coupled to each other through the ring resonator and forms four waveguide based interferometers with four input and two output ports.

NEMS-based Innervation of Materials

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We propose a concept for a novel "homogenous" material that is assembled by billions of coupled reactive NEMS. This new approach shall enable the material to show specific reactions to external inputs. Since the NEMS can communicate with each other, the reaction to the external input can be local (indicator) or general (reactive). By implementing this material into buildings, clothing or even food, it would be possible to create a virtual neural system in objects. The presentation will give an outlook on the potential of such an approach in art, science and technology and the possible impact on the life of future generations.

**CHIENHAVORN,
Orapin**

G-PO3-41, p.21/p.87

CHIN, Jitkai

G12-6, p.14/p.64

G-PO3-43, p.21/p.88

CHIN, Lip Ket

G4-3, p.5/p.34

G4-6, p.6/p.35

G8-5, p.10/p.49

G-PO3-62, p.23/p.97

G-PO3-64, p.24/p.98

CHIN, Shu Min

G3-2, p.4/p.30

CHO, Jung-Min

G-PO3-57, p.23/p.95

CHOUHURY, Deepak

G9-1, p.10/p.51

CHU, MingXing

G-PO3-39, p.20/p.86

CHUA, Ciersiang

G-PO3-10, p.16/p.70

CHUA, Kim Bock

G11-5, p.13/p.60

CHUA, Zach

G9-4, p.11/p.53

CHUANG, Ho-Chiao

G10-6, p.12/p.57

COMBARIZA, Miguel

G-PO3-26, p.18/p.78

CONTRO, Roberto

G6-2, p.7/p.40

CUI, Fangsen

G6-1, p.7/p.39

G6-5, p.8/p.42

CUI, Song

G-PO3-19, p.17/p.75

D.

DAMGHANIAN, Mitra

G4-4, p.5/p.34

G-PO3-45, p.21/p.89

DANIEL, Daniel

G9-4, p.11/p.53

DEKKERS, Matthijn

G12-3, p.14/p.63

DEMELLO, Andrew

G-PO3-38, p.20/p.85

DIAH, S. Zaleha M.

G-PO3-47, p.21/p.90

DONG, Bin

G4-7, p.6/p.36

G-PO3-73, p.25/p.103

E.

EISENBRAUN, Eric

G11-8, p.13/p.61

F.

FANG, KokBoon

G8-4, p.9/p.49

FANG, Michelle Yanyan

G3-2, p.4/p.30

FATIMATUZZAHRA BTE

R, Siti

G11-6, p.13/p.60

FENG, Hanhua

G-PO3-1, p.15/p.65

G-PO3-20, p.17/p.75

G-PO3-21, p.17/p.75

G-PO3-74, p.25/p.103

G-PO3-75, p.25/p.104

FERNANDO, Sanchitha

G7-4, p.9/p.45

G-PO3-33, p.19/p.82

FRENCH, Paddy

G-PO3-49, p.22/p.91

FRIJNS, Johan H.M.

G-PO3-49, p.22/p.91

FU, Yi

G8-5, p.10/p.49

FU, Yuan Hsing

G1-4, p.3/p.27

G3-2, p.4/p.30

G4-7, p.6/p.36

G-PO3-53, p.22/p.93

G.

G, Vijay

G7-5, p.9/p.46

GAN, Guang De

G11-5, p.13/p.60

GAO, Huajian

G6-8, p.8/p.43

GEBESHUBER, Ille

G11-7, p.13/p.61

GEBESHUBER, Ille C.

G-PO3-47, p.21/p.90

G-PO3-50, p.22/p.91

GESSEI, Tomoko

G12-5, p.14/p.64

GONG, Xiandi

G8-4, p.9/p.49

GOTTARDI, Riccardo

G6-2, p.7/p.40

GUO, Jin Lan

G11-6, p.13/p.60

GUO, Xin

G5-4, p.6/p.38

H.

HAMIDULLAH,

Muhammad

G-PO3-1, p.15/p.65

HARTMAIER, Alexander

G6-4, p.7/p.41

HARTONO, Deny

G8-3, p.9/p.48

G8-6, p.10/p.50

HATTON, T. Alan

G-PO3-42, p.21/p.87

HAYASHI, Mika

G12-5, p.14/p.64

HEIDARI, Amir

G9-6, p.11/p.54

HIRANUMA, Yoshitaka

G-PO3-39, p.20/p.86

HOMMA, Hideyuki

G-PO3-4, p.15/p.67

HSIAO, Fu-Li

G-PO3-22, p.18/p.76

HUA, Jun

G6-4, p.7/p.41

HUANG, Kuo-Yuan

G10-6, p.12/p.57

HUANG, Wei

G8-2, p.9/p.48

HUANG, Yi-Ping

G1-3, p.3/p.26

G-PO3-52, p.22/p.92

HWANG, Kehchih

G6-8, p.8/p.43

I.

IKEHARA, Tsuyoshi

G-PO3-40, p.20/p.86

ILIESCU, Ciprian

G9-1, p.10/p.51

ISHII, Tatsuya

G-PO3-4, p.15/p.67

ITABASHI, Gen

G12-5, p.14/p.64

J.

JAIN, Vipin Kumar

G-PO3-46, p.21/p.89

JANSSENS, Arjen

G12-3, p.14/p.63

JE, Minkyu

G-PO3-34, p.19/p.83

JI, Hong Miao

G-PO3-71, p.25/p.101

JI, Xin-ming

G1-3, p.3/p.26

G-PO3-52, p.22/p.92

